



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 6589

SERIAL NUMBER 10/600,332	FILING DATE 06/23/2003 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. P68917US0	
APPLICANTS Cheol Hwan Park, Seoul, KOREA, REPUBLIC OF; Dong Su Park, Gyeonggi-do, KOREA, REPUBLIC OF; Tae Hyeok Lee, Gyeonggi-do, KOREA, REPUBLIC OF; Sang Ho Woo, Gyeonggi-do, KOREA, REPUBLIC OF;					
STC ** CONTINUING DATA ***** none					
** FOREIGN APPLICATIONS ***** STC REPUBLIC OF KOREA 2002-42462 07/19/2002					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 08/26/2003					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and <i>Allowance</i> Acknowledged <i>Examiner's Signature</i> STC Initials		STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 7	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 1
ADDRESS 00136 JACOBSON HOLMAN PLLC 400 SEVENTH STREET N.W. SUITE 600 WASHINGTON , DC 20004					
TITLE Method for forming device isolation film of semiconductor device					
			<input type="checkbox"/> All Fees		